Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination CHANG, CHIH-KAI	
10/790,134		
Examiner -	Art Unit	
Jean F. Duverne	2839	

SEARCHED				
Class	Subclass	Date	Examiner	
439	676	4/27/2005	JFD	
	736			
	344			
	638-639			
	76.1			
	686			
	689	4/27/2005	JFD	
		8		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
			,	

(INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
·		
·		
		·
	-	